

**Search Notes**

Application/Control No.

10/628,466

Examiner

Michael A. Friedhofer

Applicant(s)/Patent under  
Reexamination

YEN, CHI-YU

Art Unit

2832

**SEARCHED**

Class	Subclass	Date	Examiner
200	5r,5a,512- 514,517, 341,344	3/3/2005	MAF
200	345	3/3/2005	MAF
341	22	3/3/2005	MAF
345	168,169	3/3/2005	MAF
400	490-496	3/3/2005	MAF

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
200	5r,5a	3/3/2005	MAF
200	512-514	3/3/2005	MAF
200	517,341	3/3/2005	MAF
200/344,345		3/3/2005	MAF

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR